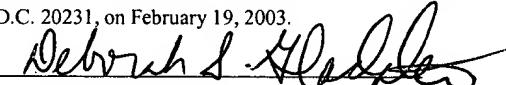




PATENT
Docket No. 204552021700

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Deborah S. Gladstein

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Tetsuyoshi INOUE et al.

Serial No.: 09/987,010

Filing Date: November 13, 2001

For: SEMICONDUCTOR LASER
MANUFACTURING METHOD AND
SEMICONDUCTOR LASER

Examiner: Tuan N. Nguyen

Group Art Unit: 2828

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AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents
Washington, D.C. 20231

Sir:

This is in response to the Office Action dated November 19, 2002. Please amend the application as follows.